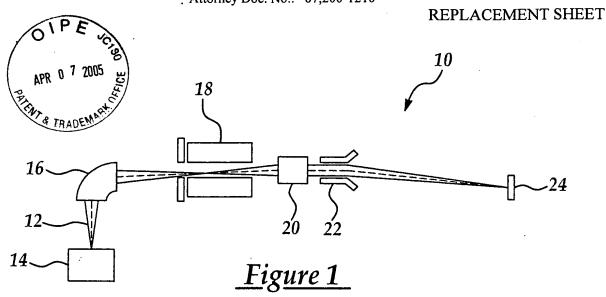
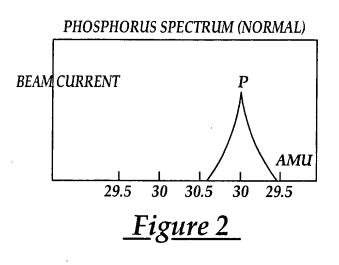
Inventor: Chen-Chung Li

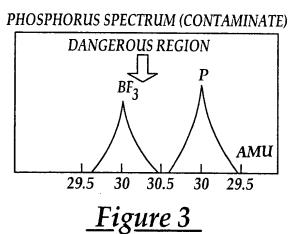
Serial No.: 10/804,890 Filed: 03/18/2004

For: Ion Implanter and Method of Preventing ... A Target Wafer

Attorney Doc. No.: 67,200-1218







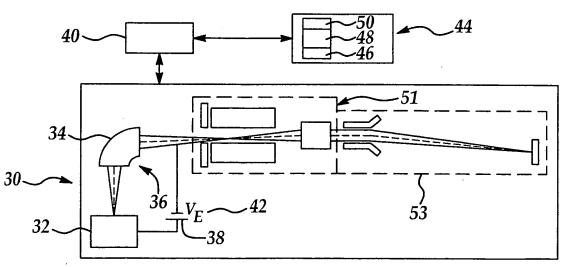


Figure 4